International **IGR** Rectifier REPETITIVE AVAILANCHE AND dv/dt RATED HEXFET® TRANSISTOR

IRHNA7264SE

N-CHANNEL

SINGLE EVENT EFFECT (SEE) RAD HARD

250Volt, 0.110 Ω , (SEE) RAD HARD HEXFET

International Rectifier's (SEE) RAD HARD technology HEXFETs demonstrate virtual immunity to SEE failure. Additionally, under **identical** pre- and post-radiation test conditions, International Rectifier's RAD HARD HEXFETs retain **identical** electrical specifications up to 1 x 10⁵ Rads (Si) total dose. No compensation in gate drive circuitry is required. These devices are also capable of surviving transient ionization pulses as high as 1 x 10¹² Rads (Si)/Sec, and return to normal operation within a few microseconds. Since the SEE process utilizes International Rectifier's patented HEXFET technology, the user can expect the highest quality and reliability in the industry.

RAD HARD HEXFET transistors also feature all of the well-established advantages of MOSFETs, such as voltage control, very fast switching, ease of paralleling and temperature stability of the electrical parameters.

They are well-suited for applications such as switching power supplies, motor controls, inverters, choppers, audio amplifiers and high-energy pulse circuits in space and weapons environments.

Part Number	BVDSS	RDS(on)	ID
IRHNA7264SE	250V	0.110Ω	34A

Features:

- Radiation Hardened up to 1 x 10⁵ Rads (Si)
- Single Event Burnout (SEB) Hardened
- Single Event Gate Rupture (SEGR) Hardened
- Gamma Dot (Flash X-Ray) Hardened
- Neutron Tolerant
- Identical Pre- and Post-Electrical Test Conditions
- RepetitiveAvalanche Rating
- Dynamic dv/dt Rating
- Simple Drive Requirements
- Ease of Paralleling
- Hermetically Sealed
- Surface Mount
- Lightweight

Product Summary

Absolute Maximum Ratings

Pre-Radiation

	Parameter	IRHNA7264SE	Units	
$I_D @ V_{GS} = 12V, T_C = 25^{\circ}C$	Continuous Drain Current	34		
$I_D @ V_{GS} = 12V, T_C = 100^{\circ}C$	Continuous Drain Current	21	A	
IDM	Pulsed Drain Current ①	136		
$P_{D} @ T_{C} = 25^{\circ}C$	Max. Power Dissipation	300	W	
	Linear Derating Factor	2.4	W/K⑤	
VGS	Gate-to-Source Voltage	±20	V	
EAS	Single Pulse Avalanche Energy ②	500	mJ	
IAR	Avalanche Current ①	34	A	
EAR	Repetitive Avalanche Energy ①	30	mJ	
dv/dt	Peak Diode Recovery dv/dt 3	4.0	V/ns	
Тј	Operating Junction	-55 to 150		
TSTG	Storage Temperature Range		°C	
	Package Mounting Surface Temperature	300 (for 5 sec.)		
	Weight	3.3 (typical)	g	

	Parameter	Min.	Тур.	Max.	Units	Test Conditions		
BVDSS	Drain-to-Source Breakdown Voltage	250	—	_	V	VGS = 0V, ID = 1.0 mA		
ΔBV _{DSS} /ΔTJ	Temperature Coefficient of Breakdown Voltage	_	_	—	V/°C	Reference to 25°C, ID = 1.0 mA		
RDS(on)	Static Drain-to-Source	—	—	0.110		VGS = 12V, ID =24A		
	On-State Resistance	—	_	0.123	Ω	VGS = 12V, ID = 34A		
VGS(th)	Gate Threshold Voltage	2.5	_	4.5	V	$V_{DS} = V_{GS}, I_{D} = 1.0 \text{ mA}$		
gfs	ForwardTransconductance	4	—	_	S (7)	VDS > 15V, IDS = 21A ④		
IDSS	Zero Gate Voltage Drain Current	—	—	50		VDS = 0.8 x Max Rating, VGS = 0		
		—	_	250	μΑ	VDS = 0.8 x Max Rating		
						VGS = 0V, TJ = 125°C		
IGSS	Gate-to-Source Leakage Forward	—	—	100	nA	VGS = 20V		
IGSS	Gate-to-Source Leakage Reverse	—	—	-100		VGS = -20V		
Qg	Total Gate Charge	—	—	185		VGS =12V, ID = 34A		
Qgs	Gate-to-Source Charge	—	—	55	nC	VDS = Max. Rating x 0.5		
Qgd	Gate-to-Drain ("Miller") Charge	—	—	180				
td(on)	Turn-On Delay Time	—	—	35		VDD = 125V, ID =34A,		
tr	RiseTime	—	—	200	ns	RG = 2.35Ω		
td(off)	Turn-Off Delay Time	—	—	140	115			
tf	FallTime	—	—	75				
LD	Internal Drain Inductance	—	2.0	—	nH	Measured from the drain lead, 6mm (0.25 in.) from package to center of die.		
ЦS	Internal Source Inductance	—	6.5	_		Measured from the source lead, 6mm (0.25 in.) from package to source bonding pad.		
C _{iss}	Input Capacitance	—	7800	_		$V_{GS} = 0V, V_{DS} = 25V$		
C _{OSS}	Output Capacitance	—	1250	—	pF	f = 1.0 MHz		
C _{rss}	Reverse Transfer Capacitance	—	550	_				

Electrical Characteristics @ Tj = 25°C (Unless Otherwise Specified)

Source-Drain Diode Ratings and Characteristics

	Parameter	Min.	Тур.	Max.	Units	Test Conditions			
IS	Continuous Source Current (Body Diode)	—	_	34	A	Modified MOSFET symbol showing the			
ISM	Pulse Source Current (Body Diode) ①	_	_	136		integral reverse p-n junction rectifier.			
VSD	Diode Forward Voltage	_	_	1.4	V	Tj = 25°C, IS = 34A, VGS = 0V ④			
trr	Reverse Recovery Time	—	—	875	ns	Tj = 25°C, IF = 34A, di/dt ≤ 100A/μs			
QRR	Reverse Recovery Charge	—	—	12	μC	V _{DD} ≤ 50V ④			
ton	Forward Turn-On Time Intrinsic turn-on time is negligible. Turn-on speed is substantially controlled by LS + LD.								

Thermal Resistance

	Parameter	Min.	Тур.	Max.	Units	Test Conditions
R _{th} JC	Junction-to-Case	—	—	0.42	K/W 5	
R _{th} J-PCB	Junction-to-PC board	_	TBD	_		soldered to a copper-clad PC board

IRHNA7264SE Device

Radiation Performance of Rad Hard HEXFETs

International Rectifier Radiation Hardened HEXFETs are tested to verify their hardness capability. The hardness assurance program at International Rectifier uses two radiation environments.

Every manufacturing lot is tested in a low dose rate (total dose) environment per MIL-STD-750, test method 1019. International Rectifier has imposed a standard gate voltage of 12 volts per note 6 and a V_{DSS} bias condition equal to 80% of the device rated voltage per note 7. Pre- and post-radiation limits of the devices irradiated to 1 x 10⁵ Rads (Si) are identical and are presented in Table 1. The values in Table 1 will be met for either of the two low dose rate test circuits that are used.

Both pre- and post-radiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison. It should be noted that at a radiation level of 1×10^5 Rads (Si), no change in limits are specified in DC parameters.

High dose rate testing may be done on a special request basis, using a dose rate up to 1×10^{12} Rads (Si)/ Sec.

International Rectifier radiation hardened HEXFETs have been characterized in neutron and heavy ion Single Event Effects (SEE) environments. Single Event Effects characterization is shown in Table 3.

Table 1. Low Dose Rate 6 7

Table 1. L	IRHNA	7264SE					
Parameter		100K Ra	ads (Si)	Units	Test Conditions 10		
		min. m	min. max.		min. max.		
BV _{DSS}	Drain-to-Source Breakdown Voltage	250	250 —		$V_{GS} = 0V, I_D = 1.0 \text{ mA}$		
V _{GS(th)}	Gate Threshold Voltage ④	2.0	4.5		$V_{GS} = V_{DS}, I_D = 1.0 \text{ mA}$		
IGSS	Gate-to-Source Leakage Forward	_	100	nA	$V_{GS} = 20V$		
IGSS	Gate-to-Source Leakage Reverse	—	-100		V _{GS} = -20V		
IDSS	Zero Gate Voltage Drain Current	_	50	μA	$V_{DS} = 0.8 \text{ x} \text{ Max} \text{ Rating}, V_{GS} = 0 \text{V}$		
R _{DS(on)1}	Static Drain-to-Source ④	_	— 0.110		VGS = 12V, I _D =21A		
	On-State Resistance One						
V _{SD}	Diode Forward Voltage ④	_	1.4	V	$T_{C} = 25^{\circ}C, I_{S} = 34A, V_{GS} = 0V$		

Table 2. High Dose Rate ®

10 ¹¹ Rads (Si)/sec 10 ¹² Rads (Si)/sec								
Parameter		Тур	Max.	Min.	Тур.	Max.	Units	Test Conditions
VDSS Drain-to-Source Voltage	—	—	200	_	—	200	V	Applied drain-to-source voltage
								during gamma-dot
IPP	—	10	—	_	10	—	A	Peak radiation induced photo-current
di/dt	—	16	—	—	2.3	—	A/µsec	Rate of rise of photo-current
L ₁	-	1	—	—	20	_	μH	Circuit inductance required to limit di/dt

Table 3. Single Event Effects (9)

Parameter	Тур.	Units	lon	LET (Si) (MeV/ma/cm²)	Fluence (ions/cm ²)	Range (um)	V _{DS} Bias	V _{GS} Bias
BVDSS	250	V	Ni	28	1 x 10 ⁵	~35	200	-5

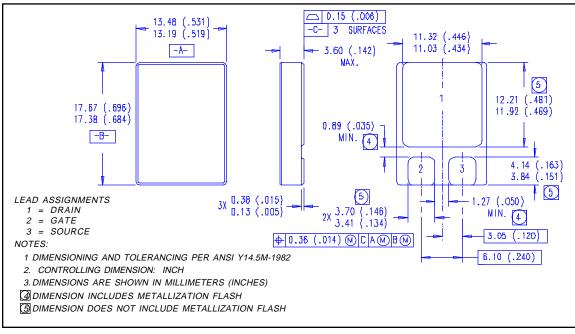
IRHNA7264SE Devices

Radiation Characteristics

- Repetitive Rating; Pulse width limited by maximum junction temperature. Refer to current HEXFET reliability report.

- (4) Pulse width \leq 300 µs; Duty Cycle \leq 2%
- (5) $K/W = {}^{o}C/W$ $W/K = W/{}^{o}C$

- 6 Total Dose Irradiation with V_{GS} Bias. 12 volt V_{GS} applied and V_{DS} = 0 during irradiation per MIL-STD-750, method 1019.
- O Total Dose Irradiation with VDS Bias. VDS = 0.8 rated BVDSS (pre-radiation) applied and VGS = 0 during irradiation per MIL-STD-750, method 1019.
- ⑧ This test is performed using a flash x-ray source operated in the e-beam mode (energy ~2.5 MeV), 30 nsec pulse.
- 9 Process characterized by independent laboratory.
- Il All Pre-Radiation and Post-Radiation test conditions are identical to facilitate direct comparison for circuit applications.



Case Outline and Dimensions — SMD-2

International **ISPR** Rectifier

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